U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
KAT		5,629,772	05-13-97	Ausschnitt			
KAT		6,421,820	07-16-02	Mansfield et al.			
KAT		6,223,139	04-24-01	Wong et al.			
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	NO

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

KAT		Appl. Ser. No. 10/353,900, filed January 28, 2003, "Integrated lithographic print and detection model for optical CD" Gordon et al.
KAT		Kenny K. H. Toh and Andrew R. Neureuther, "Identifying and monitoring effects of lens aberrations in projection printing", SPIE, Vol. 772, pp. 202-209, Optical Microlithography VI: 4-5 March 1987, Santa Clara, CA.
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KAT		H. H. Hopkins, "On the diffraction theory of optical images", proceedings of the Royal Society of London, Vol. A217 (1953), pp. 408-432

EXAMINER /Kimberly Thornewell/ (09/22/2006)	DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.